

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,709,881 B2  
DATED : March 23, 2004  
INVENTOR(S) : Yoshiaki HASEGAWA, et al.

It is certified that error appears in the above-identified patent and that said Letter Patent is hereby corrected as shown below:

On the Title Page of the Letters Patent and Column One;

Under section "(54)" and under column one, change " METHOD FOR  
MANUFACTURING SEMICONDUCTOR AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE " to – METHOD FOR  
MANUFACTURING SEMICONDUCTOR LASER OPTICAL DEVICE –

MAILING ADDRESS OF SENDER:  
McDermott Will & Emery LLP  
600 13th Street, NW  
Washington, DC 20005  
USA

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